Main Specifications	Other Specifications
▼Size	▼Cleanliness level
1.5″, 2″	AP / MP
▼Installation type	For more information plea
Bottom mount (A)	refer to cleanliness level ta
Back mount (ADC)	▼ Ring
Back mount with flange (BDC)	PC
▼ Window	Bayonet
PC, O-ring sealed	▼Case
▼ Pressure connection	SS304
Material: SS 316	▼ Pointer
1/4″ NPT	Aluminum with black enar
1/4" BSP (=G)	▼Dial face
1/4" VCR (M/F)	Blue and black scale
9/16" -18UNF(M)	Measuring elements
Fixed thread / Swivel thread	Bourdon tube
▼Pressure range	Material: SS316 / SS316L /
Gauge pressure ▼	SS316Ti
0 to 350 bar	▼Protection design
Compound pressure▼	Blow out back
-10 to 24bar	▼Movement
▼Applicable fluid	Stainless steel
Liquid and gas that compatible	▼Accuracy
with SS 316	2.5% / 1.5%
▼Ambient temperature	▼Operating pressure
-40°C to +60°C	Stabilization 3/4* full scale
▼ Fluid temperature	Fluctuation 2/3* full scale
+100°C	Impulse 1* full scale
▼ Protection level	▼Other requests (Option)
IP54	Third party notarized
	documents
	Inspection report

# evel mation please ness level table n black enamel scale lements 6/SS316L/ esign essure /4\* full scale \* full scale scale sts (Option) tarized Inspection report

Customized dial face

(scale, color)

**High Purity Pressure Gauge** Model: HCPG Introduction

HCPG High purity pressure gauge has 2 levels of cleanliness to meet various requirements and it is cleaned by ultrasonic pure water. It adopts vacuum welding, the airtightness is up to 1 x 10<sup>-9</sup> Pa • m<sup>3</sup>/s. It is especially suitable for high cleanliness requirement industry: semiconductor, medical technology, and biotechnology engineering industry.



Due to the variety of customization, the picture is only for reference, please confirm the actual item with our sales. (If there is any change on specification, please take the latest version as standard.)

### **Features**

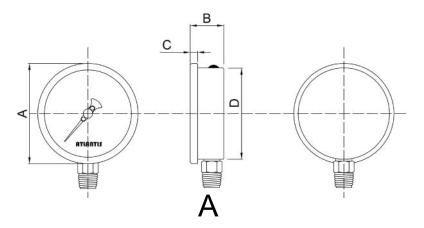
- OEM service
- Cleaned by ultrasonic & pure water
- Vacuum welding adopted
- Specially designed for semiconductor, medical technology and biotechnology engineering
- Two level cleanliness: AP / MP
- Airtightness can up to 1 x 10<sup>-9</sup> Pa m<sup>3</sup>/s
- N<sub>2</sub> is used to purge the surface of pressure gauge, seal package tightly

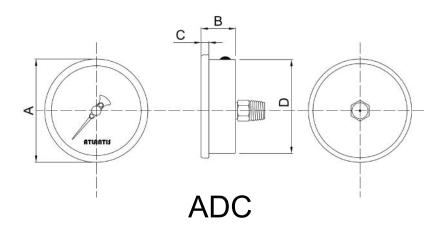
MP level adopts PET vacuum sealed package

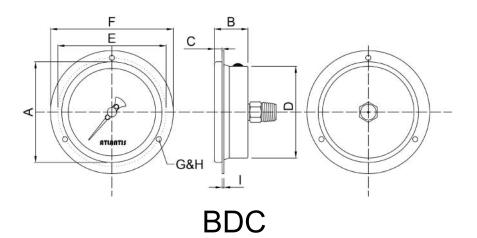
#### **Cleanliness level table**

Level	Polish treatment	Cleaning method	Cleanliness	Roughness	Assembly testing environment	Package
AP	х	Ultrasonic cleaning in medicine liquid or	х	Ra≦2.5µm	Clean room (Cleanliness 10000 ISO Class4)	N2 is used to purge the surface of pressure gauge, sealed package.
MP	Mechanical polished	Ultrasonic cleaning in pure water	Level VI (ASME B40 1 Level)	Ra≦0.4µm	Clean room (Cleanliness10000 ISO Class4) Workbench (Cleanliness 100 ISO Class2)	MP level adopts PET vacuum sealed package

## Installation type







#### How to order

HCPG	High Purity Pressure Gauge								
Std.	Spec.	Code	ltem	Code	ltem	Code	ltem	Code	ltem
2	Size	1.5	1.5″	2	2″	-	-	-	—
А	Installation type	A	Bottom mount	ADC	Back mount	BDC	Back mount with flange	-	_
2N	Pressure	2N	1/4″ NPT	2G	1/4″ BSP (=G)	UNF	9/16″-18UNF (M)	VM	1/4″ VCR (M)
	range	VF	1/4″ VCR (F)	-	-	-	-	-	-
т	Thread type	т	Fixed thread	S	Swivel thread	-	_	-	-
Custom	Pressure range 0 to 350 bar								
AP	Cleanliness level	AP	AP	MP	MP	-	-	-	-
/В	Other requests	/A	Third party notari	zed docu	ment				
		/B	Inspection report (issued by Re-Atlantis)						
		/C	Tag						

Order example: <u>HCPG</u> - <u>2</u> - <u>A</u> - <u>2N</u> - <u>T</u> - <u>(0 to 150 bar)</u> - <u>AP</u> - <u>/B</u>